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# **Silicon Photonics: Industrial Applied Materials and Technologies**

Guest Editor:

#### Prof. Dr. Kurt W. Kolasinski

Department of Chemistry, West Chester University of Pennsylvania, West Chester, PA 19383, USA

Deadline for manuscript submissions:

closed (15 December 2022)

## **Message from the Guest Editor**

Silicon photonics is among the top ten emerging technologies in microelectronics and is forecast by the MIT Communications Technology Roadmap to develop into a \$20B annual market. Silicon photonics represents a technology which on the one hand builds on the welldeveloped methods of CMOS-compatible fabrication and yet, on the other, is potentially disruptive in its promise to revolutionize high-performance computing and sensing. Practical implementation in commercial devices will require low loss waveguides, polarization handling, tunability, and hitless switching. Fundamental and applied advances have been made in areas such as silicon waveguides. optical sources. optical modulators. photodetectors, and integration. These advances rest upon myriad solutions to problems such as growth, etching and bonding of a variety of materials including not only Si and SiO<sub>2</sub> but also III-V semiconductors, lithium niobate, transparent conductive oxides or even graphene.











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### **Editor-in-Chief**

# **Prof. Dr. Giulio Nicola Cerullo**Dipartimento di Fisica, Politecnico di Milano, Piazza L. da Vinci 32, 20133 Milano, Italy

## **Message from the Editor-in-Chief**

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